



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Paul B. Mirkarimi et al.

Docket No. : CIL-10972

Serial No. : 10/086,614

Art Unit : 1762

Filed : March 1, 2002

Examiner : B. Pianalto

For : Ion-Assisted Deposition Techniques For
The Planarization Of Topological Defects

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

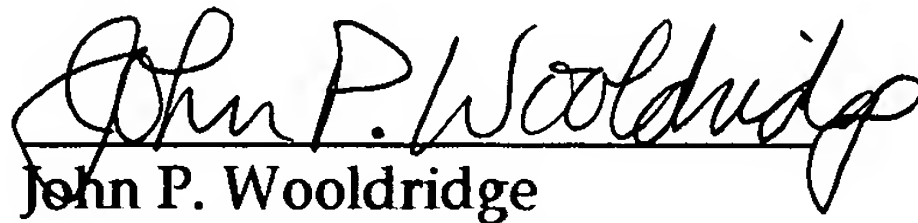
This is a request under the provisions of 37 CFR 1.136(a) to extend the period for filing a reply in the above identified application.

The requested extension fee for a one month extension (37 CFR 1.17(a)(1) is \$110.

The Commissioner is hereby authorized to charge this fee (\$110) to Deposit Account Number 501913.

If any impediments remain, please contact the undersigned at 808-270-1011.

Respectfully submitted,


John P. Wooldridge
Attorney for Applicant
Registration No. 38,725

Dated: April 9, 2004